

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for continued examination of an utility or plant application filed on or after June 8, 1995.

See The American Inventors Protection Act of 1999 (AIPA).

	$R \subset \mathcal{E}$
Application Number	09/944,983
Filing Date	August 30, 2001
First Named Inventor	Paul A. Farrar
Group Art Unit	3723
Examiner Name	Maurina Rachuba
Attorney Docket Number	1303.018US1
Customer No.	21186

This is a Request for Continued Examination (RCE) under 37 CFR § 1.114 of the above-identified application entitled CHEMICAL MECHANICAL POLISHING SYSTEM AND PROCESS.

Submission required under 37 C.F.R. § 1.114

- 1. X Consider the amendment(s)/reply under 37 C.F.R. § 1.116 previously filed on June 22, 2005.
- 2. \_ Consider the arguments in the Appeal Brief or Reply Brief previously filed on .
- 3. \_ An Amendment Under 37 CFR § 1.116 (pages) is enclosed.
- 4. \_ A new power of attorney ( pages ) is enclosed.
- 5. \_\_ An Information Disclosure Statement is enclosed (pages).
- 6.  $\underline{X}$  A check in the amount of \$790.00 is attached to pay the RCE filing fee required under C.F.R. § 1.17(e).
- 7. X The Commissioner is hereby authorized to credit overpayments or charge any fees set forth in 37 CFR §§ 1.16 through 1.18 to Deposit Account No. 19-0743.
- 8. X A Petition for Extension of Time in the prior application (1 pages) is enclosed along with a check in the amount of \$120.00 to pay the extension fee.
- 9. \_ Others:

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.	By: //
	Atty: Marvin L. Beekman
07/28/2005 MWDLDGE1 00000017 09944983	Reg. No. 38,377

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Attn-Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 45 day of July, 2005.

KACIA LEE

Signature Lacia Loo